# A Dynamic Approach to Monitoring Particle Fallout in a Cleanroom Environment

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OPTICAL SYSTEM CONTAMINATION: EFFECTS, MEASUREMENTS, AND CONTROL 2010 SAN DIEGO CONVENTION CENTER



# Introduction



□ Particle fallout levels are commonly used for:

- Estimating the effects of environmental exposure of sensitive surfaces
- Development of contamination budgets
- Standard fallout measurement approaches require durations inversely proportional to the environmental cleanliness
- Cleanrooms are certified according to airborne particle count, and many cleanrooms are equipped with continuous monitoring
- The ability to estimate particle fallout based on airborne particle counts provides a more dynamic approach

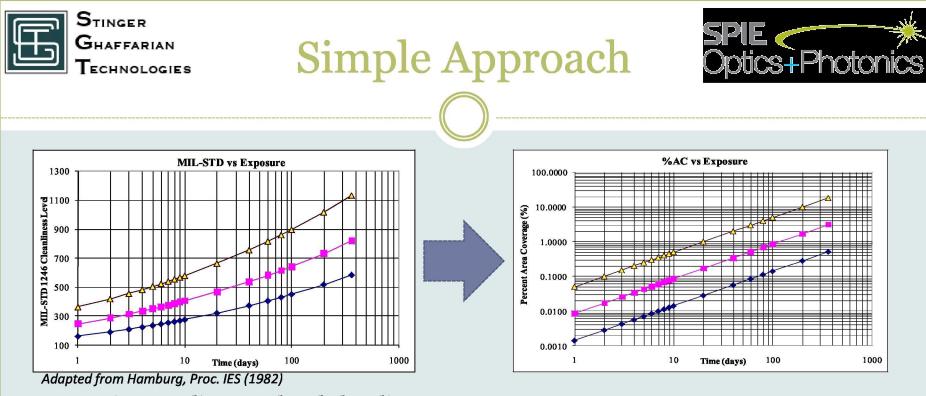








- Fallout rates are directly proportional to air quality
- Rates and quality directly reflect activity levels
- Once settled, particles remain
- Accumulation surfaces are horizontal



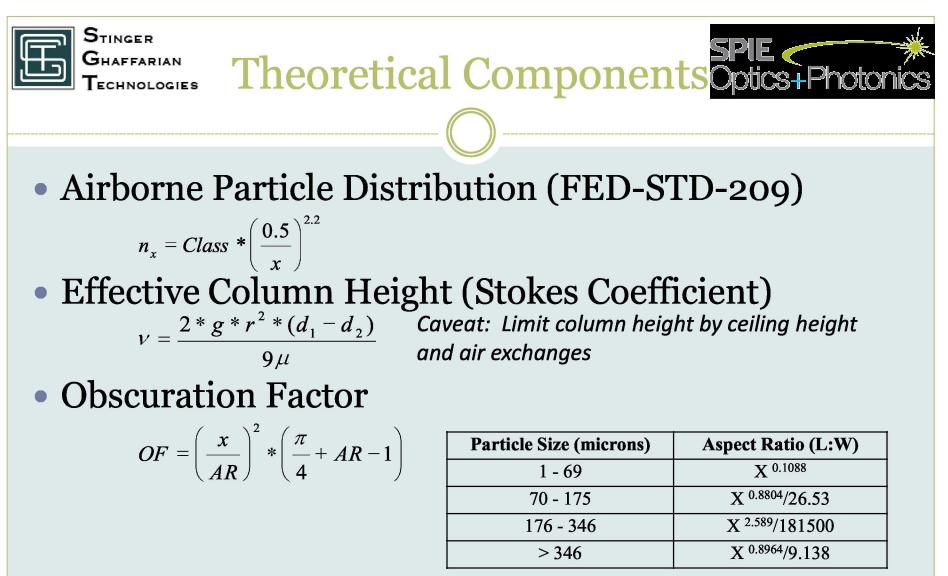
- Previous studies correlated cleanliness class to cleanliness level
  - Cleanliness level is sensitive to particle distributions
    - MIL-STD 1246 (IEST-STD-CC-1246) cleanliness levels use -0.926 distribution slope
    - × Airborne particle distribution follows a -0.28 slope
    - × Distribution of particle fallout is -0.383
  - Results in non-linear relationship

- Correlation to a normalized area coverage (e.g. PAC) provides a linear time relationship
- Simple substitution remains nonlinear for cleanroom class



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Adapted from Ma, Fong, and Lee, SPIE 1165 (1989)

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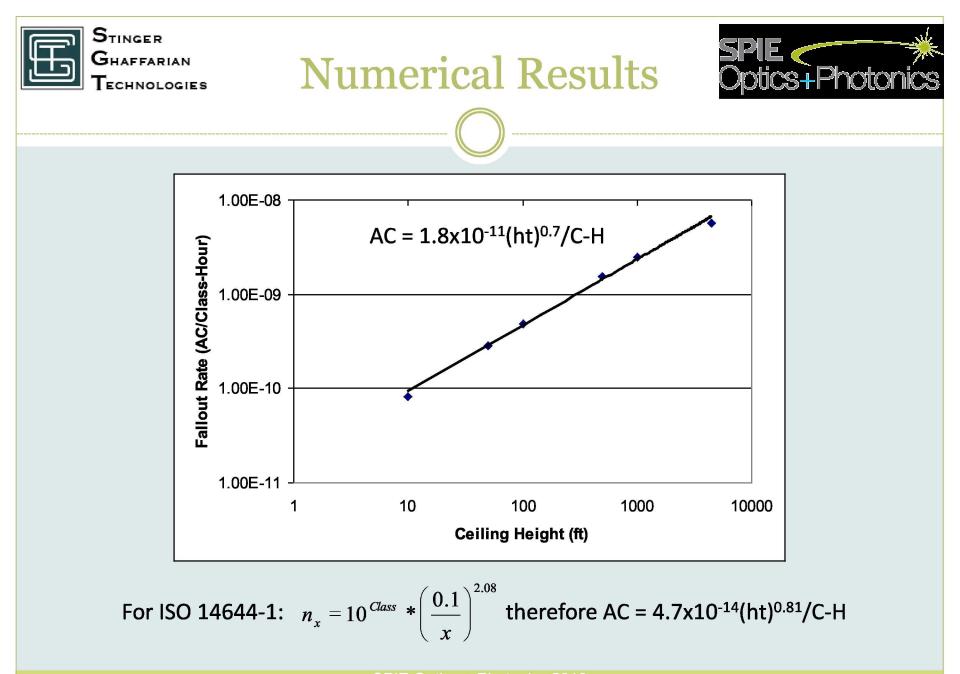


Combination of distribution, column height, and obscuration factor provides a linear correlation of area coverage (AC) to cleanroom class and time (Class-Hours)

$$AC_{x} = \left[\frac{n_{x+1} - n_{x}}{Class}\right] * \left[v_{\odot F}\right]^{*} \frac{3600 \, s}{hr} * \frac{ft}{30.48 \, cm} \right] * \left[OF * \frac{1.076 \, x10^{-11} \, ft^{2}}{\mu m^{2}}\right]$$

 A spreadsheet was used to determine the incremental contribution of AC for particles in 1 micron bins from 1 to 1000 microns





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## How To Make It Work



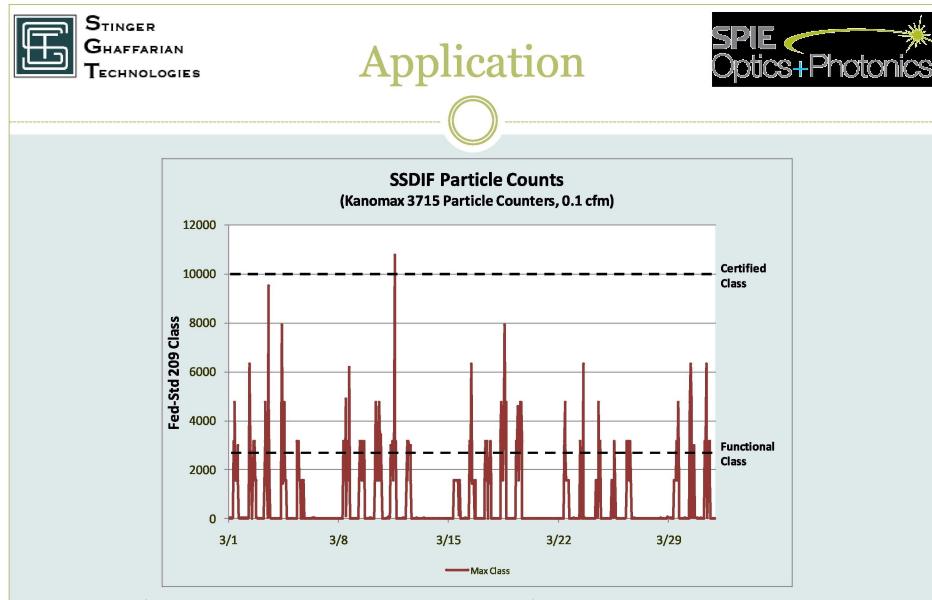
#### □ Predictive:

- Assume a limit of 0.1 PAC in a facility with a 100 foot ceiling, this results in 2.2x10<sup>6</sup> Class-Hours
  - □ For a Class 10K facility: 220 hours
  - □ For one month duration: Class 3000
- Assume covering off-shift (2/3 of each day)
  - □ For a Class 10K facility: 660 hours
  - □ For one month duration: Class 9000

### Dynamic:

- Cleanroom environments are rarely static, but vary with activity level
- Airborne particle counters can provide real-time data





□ Hourly monitoring sums to 5.15x10<sup>5</sup> Class-Hours (>75% margin)

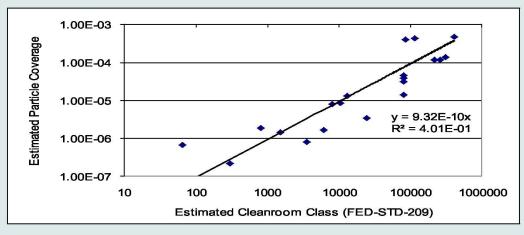
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**Supporting Evidence** 



- Ongoing monitoring at GSFC SSDIF
  - Estimated AC/C-H (100 ft ceiling): 4.5x10<sup>-10</sup>
  - {Estimated AC/C-H (43 exchanges/hr): 5.9x10<sup>-9</sup>}
  - Measured AC/C-H (5μm channel): 4.9(±8.0)x10<sup>-10</sup>
  - {*Measured AC/C-H (0.5µm channel): 4.6(±9.2)x10<sup>-9</sup>*}
- Hamburg data: 9.3x10<sup>-10</sup> AC/C-H





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